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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yu Chang Kim et al. Group Art Unit: 2812
Application Number: 10/728,812 Examiner: Lynne A. GURLEY
Filing Date: December 8, 2003 Confirmation No.: 9240
For: METHOD FOR MANUFACTURING METAL LINE OF
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action, mailed on July 13, 2005 in the above-captioned patent application, entry of the following amendments and consideration of the following remarks are respectfully requested. This response is mailed within the three-month period of response set in the Office Action, so Applicant believes that no fee is due. Nevertheless, the Commissioner is authorized to charge any additional fees that may be due for filing this response, or credit any overpayment, to Deposit Account No. 08-1641.

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.